



PATENT

-1-

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Michial Duff Howell et al

Application No.: 10/625,407

Filed: July 23, 2003

For: METHOD AND APPARATUS FOR
PREPARING SEMICONDUCTOR
WAFERS FOR MEASUREMENT

Confirmation No.: 9071

Group Art Unit: 3742

Examiner: S. T. Fuqua

**RESPONSE TO OFFICE ACTION
MAILED MAY 5, 2004**

353 Sacramento Street, Suite 2200
San Francisco, CA 94111
(415) 772-4900

M/S AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited
with the United States Postal Service as First Class Mail in an
envelope, addressed to: Commissioner for Patents, P.O.
Box 1450, Alexandria, VA 22313-1450 on August 2, 2004.

STALLMAN & POLLOCK LLP

Dated: 08/2 /2004

By:

Georgia K. Stith
Georgia K. Stith

Sir:

In response to the Office Action mailed May 5, 2004, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Remarks/Arguments begin on page 3 of this paper.